



FFN  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yasuhiko ONISHI et al

Serial No.: 10/735,501                          Group Art Unit:2811

Filed: December 12, 2003                          Examiner:

For: SUPER-JUNCTION SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME

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By: Marc A. Rossi

Marc A. Rossi

STATUS INQUIRY LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It would be appreciated if you would indicate the status of the above-identified  
application below, including an indication as to when the next communication can be expected,  
and return this sheet to the undersigned.

Respectfully submitted,

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Date: 12/10/04

Attorney Docket No. FUJI:180A

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